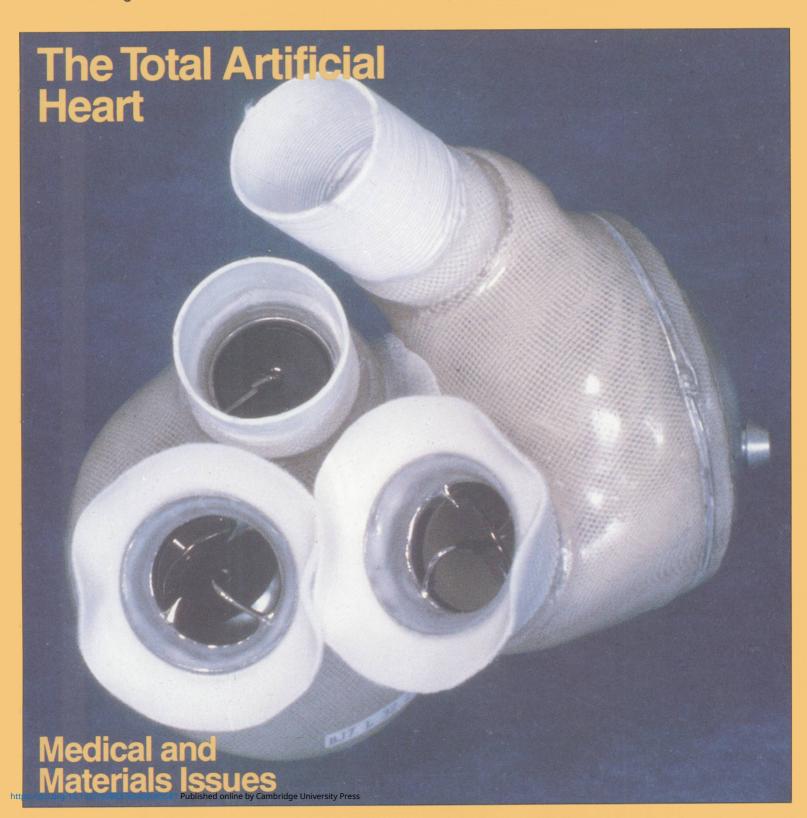
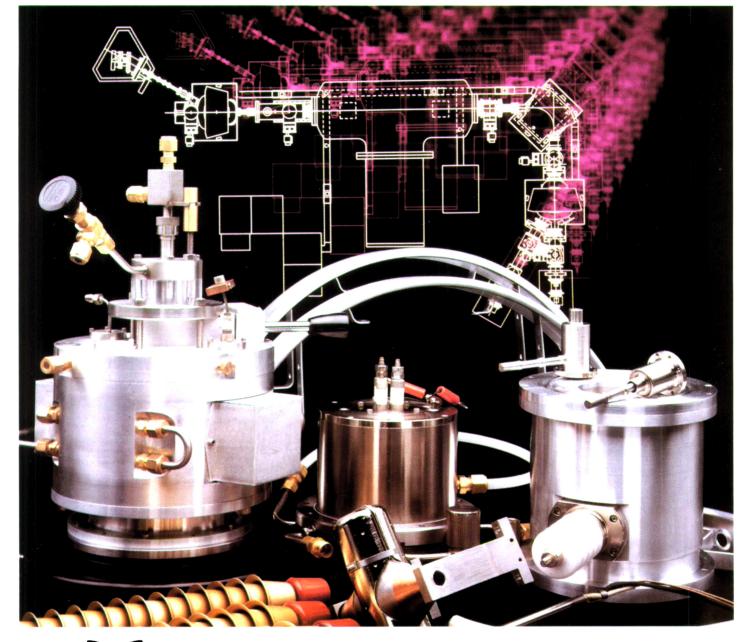
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Volume XIII, Number 5 ISSN: 0883-7694 CODEN: MRSBEA

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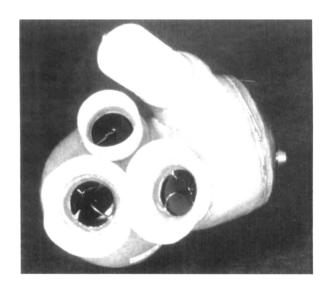
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ON THE COVER: The Jarvik artificial heart has a polyurethane rigid casing, a polyurethane diaphragm, and four clinical-grade valves. The two sections of this heart are connected by Velcro and replace the ventricles of the human heart. The Jarvik is powered outside the body by either the large Utah drive or the portable Heimes drive system. This model of the Jarvik heart was used for William Schroeder. See "Medical and Materials Issues of the Total Artificial Heart" by Dr. William C. DeVries on p. 25.

RISIBULLETIN

Materials Research Society • 9800 McKnight Road, Suite 327 • Pittsburgh, PA 15237

MRS BULLETIN

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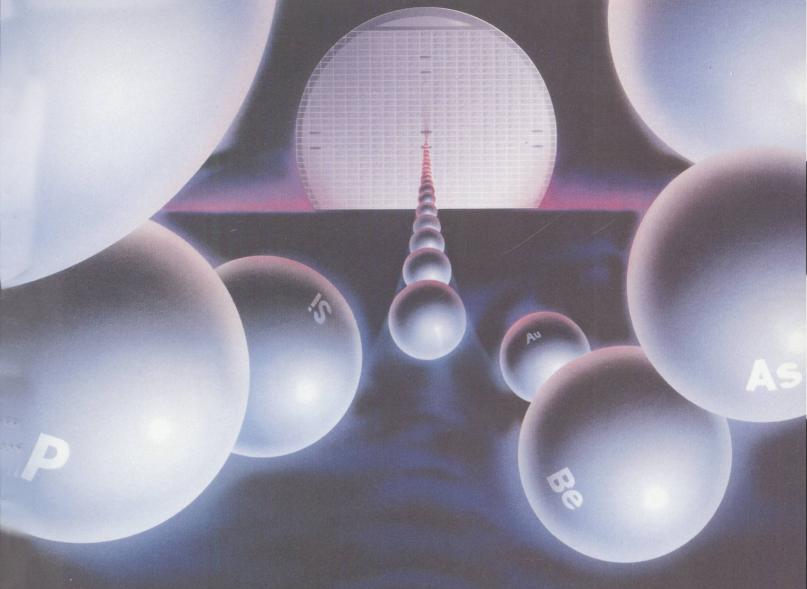
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